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PATENT
Customer No. 22,852
Attorney Docket No. 08137.0004-00000

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Hiroshi SHINRIKI et al.

Application No.: 09/657,627

Filed: September 8, 2000

For: THIN FILM FORMING METHOD
AND THIN FILM FORMING
APPARATUS

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) Group Art Unit: 1762
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) Examiner: B. Chen
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Commissioner for Patents
Washington, DC 20231

Sir:

AMENDMENT

Pursuant to a Request for Continued Examination under 37 C.F.R. § 1.114 and
fee payment filed concurrently herewith, please amend the application as follows:

IN THE CLAIMS:

Please amend claim 13, as follows:

C1
10 13. (Amended) The method of claim 1, wherein a solution, in which an organic
metal source of lead, an organic metal source of zirconium, and an organic metal
source of titanium are dissolved, is transported to a vaporizer, and, by respectively
vaporizing said organic metal sources by vaporizing said solution, each of said metal
source gases is generated.

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